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**FACSIMILE COVER SHEET**

To: Examiner George A. Goudreau Technology Center 1700	Total Pages Sent: 2 (including cover sheet)
Facsimile Number: 571-273-8300	Transmission Date: January 4, 2006

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

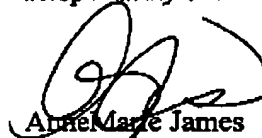
Applicant: Luctzen, et al. Docket No.: INF-115  
Serial No: 10/721,225 Art Unit: 1763  
Date Filed: November 26, 2003  
Title: Method and Structures for Increasing the Structure Density and the Storage Capacitance in a Semiconductor Wafer

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I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on the date shown above:

- Certification of Facsimile Transmission (1 page)
- Election (1 page)

Respectfully submitted,

  
Anne Marie James  
Legal Assistant

**Confirmation Respectfully Requested**

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Luetzen, et al. Docket No.: INF-115  
Serial No.: 10/721,225 Art Unit: 1763  
Filed: 11/26/2003 Examiner: George A. Goudreau  
Title: Method and Structures for Increasing the Structure Density and the Storage Capacitance in a Semiconductor Wafer

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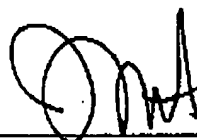
Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

ELECTION

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed on December 9, 2005, the Applicant hereby elects Group I (claims 1-13) for further prosecution in the above patent application.

Respectfully submitted,



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